SHEET 1 OF 2

Form PTO 1449	U.S. DEPARTMENT OF COMMERCE			ATTY DOCKET NO.		SERIAL NO.		
(Modified) PATENT AND TRADEMARK OFFICE			254616US40PCT	09/101,833				
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LIST OF	REFER	RENCES CITED BY AP	PLICANT	Yasuji HIRAMATSU			·	
				FILING DATE		GROUP 1793		
				January 29, 1999				
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/G.E./	AA	4,708,545	11/24/1987	Fujil, et al.				
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		NUMBER	DATE	COUNTRY				NO
/G.E./	AO	03-011571	01/18/1991	Japan w/English Abstract		ļ		X
1	AP	04-115517	04/16/1992	Japan w/English Abstract				X
	AQ	05-318160	12/03/1993	Japan w/English Abstract				X
	AR	06-120683	04/28/1994	Japan w/English Abstract				X
	AS	06-269969	09/27/1994	Japan w/English Abstract				Х
	AT	61-125715	06/13/1986	Japan w/English Abstract				Х
$ \Psi$	AU	62-004503	01/10/1987	Japan w/English Abstract				Х
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	AX		,,,,,					
	AY							
	AZ				Add	litional Ref	erences st	neet(s) attached
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Form PTO 1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO.		SERIAL N	10.		
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LIST OF	REFER	RENCES CITED BY AF	PLICANT	Yasuji HIRAMATSU					
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/G.E./	AA	5,751,585	05/12/1998	Cutler, et al.					
1	AB	5,764,485	06/09/1998	Lebaschi					
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